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IN THE UNITED STATES PATENTS AND TRADEMARK OFFICE

D-1221

Applicant : Koki Tanaka et al.  
Title : MAINTENANCE SYSTEM FOR ANALYZING INSTRUMENT  
Serial No. : 10/029,796  
Filed : December 31, 2001  
Group Art Unit : 2857  
Examiner : Carol S. Tsai

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Hon. Commissioner for Patents  
P.O. Box 1450, Alexandria, VA 22313-1450

January 12, 2004

AMENDMENT AFTER FINAL ACTION

Sir:

In response to the final Action of October 14, 2003, please amend the application, as follows:

Amendments to the Claims

Remarks